

Docket No.: 30256/39669

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Ali A. Said et al.

Application No.: 10/676,972

Art Unit: 2874

Filed: September 30, 2003

Examiner: Not Yet Assigned

For:

WAVEGUIDE FABRICATION METHODS

AND DEVICES

## **INFORMATION DISCLOSURE STATEMENT (IDS)**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A copy of each reference on the form PTO-1449 is attached.

Application No.: 10/676,972 Docket No.: 30256/39669

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith to our Deposit Account No. 13-2855, under Order No. 30256/39669. A duplicate copy of this paper is enclosed.

Dated: May 13, 2004

Respectfully submitted

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Form PTO-1449 (Modified)	Atty. Docket No.	Serial No.
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INFORMATION DISCLOSURE STATEMENT	Ali A. Said et al.	
( MAY 1 7 2004 )	Filing Date	Art Unit
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TRADEMARY PAGE		

Examiner Initials	Document Number	Issue or Publication Date	Name	Class	Subclass	Filing Date (If Appropriate)
	US 2001/0021293	09-13-2001	Kouta, et al.			
	US 2002/0085824	07-04-2002	Dugan et al.			
	US 2003/0035640	02-20-2003	Dugan et al.			``
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	6,628,877	09-30-2003	Dugan et al.			

FOREIGN PATENT DOCUMENTS					
Examiner Initials	Document Number	Publication Date	Country	Tran Yes	slation No

	Poumellec, "Femtosecond laser irradiation stress induced in pure silica," <i>Optics Express</i> , 11(9):1070-1079 (2003)
•	Schaffer, et al., "Micromachining bulk glass by use of femtosecond laser pulses with nanojoule energy," <i>Optics Letters</i> <b>26</b> (2):93-95 (2001)